



DECLARATION

As a below named inventor, we hereby declare that:

My residence, post office address and citizenship are as stated below next to my name; that

We verily believe we are the original, joint inventors of the invention entitled:

MODIFIED SOURCE/DRAIN RE-OXIDATION METHOD AND SYSTEM (MIO 0053
PA; 98-0110), described and claimed

 X in the attached specification;
 in the specification filed _____, as U.S. Application Serial No. _____
 , and as amended _____.

We hereby state that we have reviewed and understand the contents of the above identified specification, including the claims as filed and as amended by any amendment referred to above.

We acknowledge the duty to disclose to the Patent and Trademark Office all information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, §1.56(a).

We further declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under §1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Full name of sole or first Inventor: Paul J. Rudeck

Inventor's signature Paul J. Rudeck

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20072015-020702

Full name of second Inventor: Francis Benistant

Inventor's signature _____

Date: _____

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Inventor's signature Kelly J. Hurley

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200702-02020-51024001

POWER OF ATTORNEY

Applicants: Paul J. Rudeck, Francis Benistant and Kelly Hurley
Application No.: _____ Filed: _____
Entitled: MODIFIED SOURCE/DRAIN RE-OXIDATION METHOD AND SYSTEM

CERTIFICATE UNDER 37 CFR 3.73(b)

Micron Technology, Inc., a corporation of the State of Delaware, with a place of business at 8000 S. Federal Way, Boise, ID 83706-9632 certifies that it is the assignee of the entire right, title and interest in the patent application identified above by virtue of either:

A. ☒ An assignment from the inventor(s) of the patent application identified above, a copy of which is attached.

OR

B. ☐ A chain of title from the inventor(s), of the patent application identified above, to the current assignee as shown below:

1. From: _____ To: _____

The document was recorded in the Patent and Trademark Office at
Reel ____ Frame ____, or for which a copy thereof is attached.

2. From: _____ To: _____

The document was recorded in the Patent and Trademark Office at
Reel ____ Frame ____, or for which a copy thereof is attached.

3. From: _____ To: _____

The document was recorded in the Patent and Trademark Office at
Reel ____ Frame ____, or for which a copy thereof is attached.

☐ Additional documents in the chain of title are listed on a supplemental sheet.

☐ Copies of assignments or other documents in the chain of title are attached.

The undersigned has reviewed all the documents in the chain of title of the patent application identified above and, to the best of undersigned's knowledge and belief, title is in the assignee identified above.

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The undersigned (whose title is supplied below) is empowered to sign this certificate on behalf of the assignee.

Micron Technology, Inc. hereby appoint the following attorney(s) and/or agent(s) to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith:

Richard A. Killworth	Reg. No. 26,397
James F. Gottman	Reg. No. 27,262
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Micron Technology, Inc. hereby declares that all statements made herein of my own knowledge are true, and that all statements made on information and belief are believed to be true; and further, that these statements are made with the knowledge that willful false statements, and the like so made, are punishable by fine or imprisonment, or both, under Section 1001, Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Date: 11/12/00

Name: Michael L. Lynch

Title: Chief Patent Counsel

Signature: [Signature]

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**MICRON TECHNOLOGY, INC.
ASSIGNMENT OF INVENTIONS AND RIGHTS**

In consideration of my employment by, or contracting for my services with, MICRON TECHNOLOGY, INC. or any of its subsidiary companies (hereinafter collectively referred to as "Micron"), I hereby agree as follows:

1. Definitions.

a) "Invention" includes all discoveries, concepts, processes, diagrams, methods, formulae, ideas, and techniques made or conceived by myself, whether or not during working hours and whether or not with the use of Micron's or its customers' facilities, materials, or personnel, either solely or jointly with others during the period of, or as a result of, my employment by, or service to, Micron if based on or related to subject matter within a field of interest to Micron.

b) "Material" includes all works of authorship, artistic expressions, diagrams, concepts, formulae, mask works, marks, documents, drawings, logos, or ideas which may be registered, trademarked, or copyrighted under any U.S. or foreign statute or procedure made or conceived by myself whether or not during working hours and whether or not with the use of Micron or its customers' facilities, materials, or personnel, either solely or jointly with others during the period of, or as a result of, my employment by, or service to, Micron if based on or related to subject matter within a field of interest to Micron.

2. Assignment.

a) I hereby assign to Micron all of my rights to Inventions and Materials and to U.S. and foreign patent applications and patents granted and to U.S. and foreign applications for and granted registrations, trademarks, or copyrights based upon such Inventions and Materials.

b) I shall acknowledge and deliver promptly to Micron, without charge to Micron but at its expense, such written instruments and do such other acts, such as giving testimony in support of Micron's inventorship and ownership, as may be necessary in the opinion of Micron to obtain and maintain for Micron U.S. and foreign patents, registrations, trademarks, and copyrights based upon Inventions and Materials and to vest in Micron my entire right, title, and interest in Inventions and Materials.

c) I shall promptly and fully inform Micron of Inventions and Materials by written report setting forth in detail the procedures employed and results achieved. I will submit a report upon completion of any studies or research project undertaken on Micron's behalf, whether or not in my opinion a given project has resulted in an Invention or Material.



Employee/Contractor

06/26/96

Date